

Notice of References Cited	Application/Control No. 10/535,270	Applicant(s)/Patent Under Reexamination NEWKIRK ET AL.	
	Examiner Qiuwen Mi	Art Unit 1655	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0018197	08-2001	Wong et al.	435/68.1
*	B	US-5,834,286	11-1998	Nevalainen et al.	435/196
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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